IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Masuo SUZUKI et al.

Group Art Unit: 3723

Application Number: 10/551,457

Examiner: Maurina T. RACHUBA

Filed: September 30, 2005

07/19/2007 17:03 FAX 202 822 1111

Confirmation Number: 4414

For:

POLISHING PAD, PRODUCTION METHOD THEREOF, AND POLISHING

METHOD USING THE SAME

Attorney Docket Number:

053197

Customer Number:

38834

VIA FACSIMILE - 61 pages (including this cover)

Commissioner for Patents POB 1450, Alexandria, VA 22313-1450 Transmitted to USPTO Central Fax No. 571-273-8300

SUBMISSION OF DOCUMENTS

Sir:

Applicants hereby transmit the attached "Information Disclosure Statement (2 pp), PTO/SB08 (1 pp), WO03/032379 A1 with abstract (34 pp) and Chinese Office Action dated April 20, 2007 (mailing date) and issued in corresponding Chinese Patent Application Number 2004800090869 (7 pp) and its English translation (16 pp) in connection with the above-identified application.

CERTIFICATE OF TRANSMISSION

I hereby certify that the attached Information Disclosure Statement (2p), Form PTO/SB/08 (1p), WO03/032379 A1 (34 pp) and Chinese Office Action dated April 20, 2007 (mailing date) and issued in corresponding Chinese Patent Application Number 2004800090869 (7 pp) and its English translation (16 pp) are being formally transmitted via the USPTO Central Fax No.571-273-8300 on July 19, 2007.

Reg. No. 41.441

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INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97(c)(1)/(e)(1)

Mail Stop Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 July 19, 2007

Sir:

Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached Form PTO/SB/08.

This Information Disclosure Statement is being submitted after issuance of a first official action on the merits and expiration of the three month period following the filing date or the entry of the national stage for the above-captioned application, but prior to issuance of either a final official action or a Notice of Allowance. A check is attached hereto which covers the \$180.00 fee set forth in 37 C.F.R. §1.17(p).

A copy of each non - U.S. document is attached.

In compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3) for foreign language documents, Applicants enclose herewith a copy a Chinese Office Action dated April 20, 2007 (mailing date), discussing the listed documents, issued in corresponding Chinese Patent Application Number 2004800090869, together with an English language translation. The

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Information Disclosure Statement under 1.97(c)(1)/(e)(1) Attorney Docket No. 053197 Application No. 10/551,457

Chinese Office Action also discusses JP2002-166352 and JP2—3-80450 and it is therefore also submitted further in compliance with the concise explanation requirement for the foreign language documents JP2002-166352 and JP2003-80450.

Additionally, US 2004/0224623A1 is a corresponding application to WO03/032379.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

July Lee C. Wright

Attorney for Applicants
Registration No. 41,441

Telephone: (202) 822-1100 Facsimile: (202) 822-1111

LCW/af

Enclosures:

PTO/SB/08

Foreign Communication

1 reference

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that the attached Information Disclosure Statement (2p), Form PTO/SB/08 (1p), WO03/032379 A1 (34 pp) and Chinese Office Action dated April 20, 2007 (mailing date) and issued in corresponding Chinese Patent Application Number 2004800090869 (7 pp) and its English translation (16 pp) are being formally transmitted via the USPTO Central Fax No.571-273-8300 on July 19, 2007.

Lee C. Wright

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Combined Form PTO/SB/08A&B				Application Number	10/551,457	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Confirmation Number	4414 September 30, 2005	
				Filing Date		
				First Named Inventor	Masuo SUZUKI et al.	
				Art Unit	3723	
(add an interly product and interesting)				Examiner Name	Maurina T. RACHUBA	
Sheet	1	of	1	Attorney Docket Number	053197	

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document No	umber	Publication Date		
		Number	Kind Code ¹ (tf known)	MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	
	1.	US 6,533,645	B2	03-18-2003	Tolles	
	2.	US 2002/0049033	Al	04-25-2002	Newell	
	3.	US 2004/0224623	Al	11-11-2004	Nishiyama et al.	
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		FOREIGN PATENT DOCUMENTS						
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	4.	WO	03/032379	A1	04-17-2003	HITACHI CHEMICAL CO., LTD.	Abst	ract.
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Examiner Signature Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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